## Notice of References Cited Application/Control No. 10/767,726 Examiner Thomas D. Lee Applicant(s)/Patent Under Reexamination OGAWA, HIDEHIKO Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,742,769	04-1998	Lee et al.	709/206
*	В	US-5,798,845	08-1998	Baek et al.	358/434
	С	US-			
	D	US-			
	Ε	US-			
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*	:	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
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	Т					

## **NON-PATENT DOCUMENTS**

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